

Electronic Patent Application Fee Transmittal

Application Number:	10733201			
Filing Date:	09-Dec-2003			
Title of Invention:	ATOMIC LAYER DEPOSITION METHOD OF DEPOSITING AN OXIDE ON A SUBSTRATE			
First Named Inventor/Applicant Name:	Garo J. Derderian			
Filer:	Mark S. Matkin/Lori Tetrault			
Attorney Docket Number:	MI22-2402			
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Utility under 35 USC 111(a) Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Utility Appl issue fee	1501	1	1440	1440
Publ. Fee- early, voluntary, or normal	1504	1	300	300

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
Printed copy of patent - no color	8001	1	3	3
Total in USD (\$)				1743